

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/614,807
Filing Date July 9, 2003
Inventor Vladimir Segal et al.
Assignee Honeywell International Inc.
Group Art Unit 1742
Examiner Wilkins III, Harry D.
Attorney's Docket No. 30-5004-CIP
Title: Copper Sputtering Targets and Methods of Forming Copper Sputtering Targets

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included with the exception of U.S. patents and published U.S. applications (1273 Off. Gaz. Pat. Off. 55, 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

This Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action on the merits, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this information disclosure statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Respectfully submitted,

Dated: October 19, 2005

By: 

Jennifer J. Taylor, Ph.D.

Reg. No. 48,711

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. 30-5004CIP		SERIAL NO. 10/614,807	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Wuwen Yi et al.			
					FILING DATE July 9, 2003		GROUP 1742	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Sub- class	Filing Date If Appropriate	
	AA	5,415,829	05-1995	Ohhashi et al.				
	AB							
	AC							
	AD							
	AE							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Sub- class	Translation	
							Yes	No
	AF							
	AG							
	AH							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AK							
	AL							
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